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## BIB DATA SHEET

CONFIRMATION NO. 3043

<b>SERIAL NUMBER</b> 10/617,747	<b>FILING or 371(c) DATE</b> 07/14/2003 <b>RULE</b>	<b>CLASS</b> 427	<b>GROUP ART UNIT</b> 1762	<b>ATTORNEY DOCKET NO.</b> 109100.01		
<b>APPLICANTS</b> Nobuko Okada, Suwa-shi, JAPAN; Shunichi Seki, Suwa-shi, JAPAN; Katsuyuki Morii, Suwa-shi, JAPAN;						
<b>** CONTINUING DATA *****</b> This application is a DIV of 09/820,650 03/30/2001 PAT 6,623,097						
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-098161 03/31/2000 JAPAN 2000-376294 12/11/2000						
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 06/21/2004						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/JAMES LIN/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 9	<b>TOTAL CLAIMS</b> 16	<b>INDEPENDENT CLAIMS</b> 16
<b>ADDRESS</b> OLIFF & BERRIDGE, PLC P.O. BOX 19928 ALEXANDRIA, VA 22320 UNITED STATES						
<b>TITLE</b> Thin film formation method by ink jet method, ink jet apparatus, production method of organic EL device, and organic EL device						
<b>FILING FEE RECEIVED</b> 1842	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			